



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81015

Shuho MOTOMURA

Appln. No.: 10/820,752

Confirmation No.: 8798

Group Art Unit: 1762

Filed: April 9, 2004

Examiner: Katherine A. Bareford

For: SUBSTRATE PROCESSING SYSTEM, COATING APPARATUS, AND COATING  
METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 21, 2007, please amend the above-identified application as follows on the accompanying pages.